



1765

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

Applicant: Nakamura et al.

Serial No.: 09/856,212

Filed: May 18, 2002

For: **PRODUCTION METHOD FOR SILICON
SINGLE CRYSTAL WAFER**

Examiner: Matthew J. Song

Art Unit: 1765

Confirmation No.: 9409

I hereby certify that this correspondence is
being deposited with the United Postal
Service as first class mail in an envelope
addressed to: Mail Stop NON-FEE
AMENDMENT, Commissioner of Patents,
P.O. Box 1450, Alexandria, VA, 22313-
1450, on

April 5, 2004

Gerald T. Shekleton
Gerald T. Shekleton Reg. No. 27,466

AMENDMENT

Mail Stop NON-FEE AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The office action of January 14, 2004 has been carefully reviewed and the following
amendments and remarks are made in response thereto.

ENTDud
N/RCE
dtd
5/14/04